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MI22-1544

Application Serial No. 09/677,478 Response to March 16, 2004 OA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No
Filing Date October 2, 2000
Inventor
Assignee Micron Technology, Inc.
Group Art Unit
Examiner Lan Vinh
Attorney's Docket No MI22-1544
Title: Plasma Etching Methods

RESPONSE TO MARCH 16, 2004 OFFICE ACTION

To:

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

From:

D. Brent Kenady

Tel. 509-624-4276; Fax 509-838-3424

Wells St. John P.S.

601 W. First Avenue, Suite 1300

Spokane, WA 99201-3828

Responsive to the Office Action dated March 16, 2004, Applicant amends and remarks as follows:

AMENDMENTS

Underlines indicate insertions and strikeouts indicate deletions.